



PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki NAGASAKA

Group Art Unit: 2882

Application No.: 10/584,950

Examiner: P. KIM

Filed: July 5, 2006

Docket No.: 128620

For: EXPOSURE APPARATUS, EXPOSURE METHOD, AND DEVICE PRODUCING
METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 1. This Information Disclosure Statement is being filed with a Request for Continued Examination. No certification or fee is required.
- 2. An International Search Report was issued in a counterpart foreign or international application. An original English language version of the International Search Report is attached as Reference 2. The references cited therein have already been made of record in this application.

3. Reference 1 corresponds to Reference 3 cited in the Information Disclosure Statement filed December 10, 2010.

Respectfully submitted,

Mario A. Costantino
Registration No. 33,565

Justin T. Lingard
Registration No. 61,276

MAC:JTL/emd

Date: March 28, 2011

OLIFF & BERRIDGE, PLC
P.O. Box 320850
Alexandria, Virginia 22320-4850
Telephone: (703) 836-6400

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